

Patent Application Transmittal (only for new nonprovisional applications under 37 C.F.R. 1.53(b))

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Date: <u>August 30, 2001</u> Attorney Docket No.: 450100-03436

ASSISTANT COMMISSIONER FOR PATENTS Box Patent Application Washington, D.C. 20231

Sir:

With reference to the filing in the United States Patent and Trademark Office of an application for patent in the name(s) of:

## Hironaga NAKATSUKA

entitled:

MODEL ADAPTATION APPARATUS, MODEL ADAPTATION METHOD, STORAGE MEDIUM, AND PATTERN RECOGNITION APPARATUS

The following are enclosed:  X Specification (57 pages) X 16 Sheet(s) of Drawings X 12 Claim(s) (including 4 independent claim(s)) This application contains a multiple dependent claim	
X Our check for \$ 790.00 , calculated on the basis of the claims amended by any enclosed preliminary amendment as follows:	as
Basic Fee, \$710.00 (\$355.00)	0- 80.00 -0- 790.00
<pre>X Oath or Declaration and Power of Attorney     X New</pre>	
X Certified copy of each of the following application(s) to substan the claim(s) for priority made in the Declaration:	tiate
Application No. Filed In	

Application No.

2000-264035

31 August 2000

Japan

Please charge any additional fees required for the filing of this application or credit any overpayment to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP Attorneys for Applicant

William S. Frommen

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Assistant Commissioner for Patents

Washington, D.C. 20231

Re:

U.S. Patent Application

Applicant: Hironaga NAKATSUKA

Our Ref.: 450100-03436

Dear Sir:

Enclosed are papers constituting the above patent application which is being filed under 37 C.F.R. 1.53 without a signed Declaration. Please accord a filing date and a serial number to such application and inform the undersigned thereof so that a signed Declaration and the surcharge required by 37 C.F.R. 1.16(e) may be duly filed.

Please address all correspondence to:

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Respectfully,

William S. Frommer

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**Enclosures** 

"Express	Mail"	mailing	label	number	EL742667531US			
Date of I	Deposit				August	30,	2001	

I hereby certify that this paper or fee, and a patent application and accompanying papers, are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and are addressed to the Assistant Commissioner for Patents, Washington, DC 20231.

(Typed or printed name of person mailing paper or fee)

(Signature of person mailing paper or fee)